My Wish List for Detector Development Facilities 4/17 R.J. Tesarek

Neutrons



Capability Expansion/Upgrades (1)

Thin films facility used by various divisions/users (coatings, mirroring, diamond polishing, etc)

Thin Films Facility Investments:

- ⇒Photolithography
 - Allow for surface metallization of complex patterns
 - Enhance existing facilities
- →Oxygen Plasma Etch Machine
 - Aid in surface preparation for adhesion of thin films
 - Supplement/enhance existing facilities
- →Surface Materials Scientist/Chemist
 - Better understanding of processes
 - Assist with coatings, etc.

Example: Diamond Microstrip Detector







Fig. 3. Schematic view of the diamond microstrip detector.

F.Borchelt, et al., NIM A354 (1995) 318-327.

Capability Expansion/Upgrades (2)

Scintillators PMT assemblies used for test stands and test beam (triggers)

Scintillator Assembly/Maintenance Investments:

- ⇒(Re-)establish scintillator "shop" (Lab 6)
 - Catalog supply of PMT/bases
 - Scintillator machining, wrapping, testing
- Hire/Train new person to make/maintain scintillator detectors for test stands/ beam
 - Anatoly Ronzhin will retire someday
 - Capture/retain competence
- Development of radiation tolerant scintillators for future experiments



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Capability Expansion/Upgrades (3)

Intensity frontier experiments need access to lower energy particles to test/ characterize detector performance.

eg: NOvA, Short Baseline Neutrino Program, Mu2e observed particles < 5,000 MeV/c

Test Beam Investments:

⇒Add low energy beamline (capability)

- Momentum selection 100 5,000 MeV/c
- 500 5,000 MeV/c short lived particles (K, π , μ)
- \cdot 100 MeV/c long lived particles e,p (µ)
- Rates > 1 Hz over momentum range
- →Irradiation Facility:
 - 100-500 MeV protons
 - Beam size few cm across (tunable)
 - $\Phi \sim 1e4 1e12 \text{ p/cm}^2/\text{s}$ (tunable)
 - Proximity of irradiation and test facilities